

IIT Bombay Nanofabrication Facility Dept of Electrical Engg, Annexe IIT Bombay, Powai, Mumbai - 400076 (022)25764435



User Informati Name of the use					
Email:					
Phone Number:					
Faculty/ Guide N	ame:				
Sample Inform	ation				
Substrate Size: _					
Sample Proces Was the sample		•			
□ Yes □ No					
	-	ibs outside IITBNF ed outside IITBNF	at any intermediate	e process step is	
Sample History	<b>/ *</b>				
Step	Process	Equipment Used	Equipment Category (Clean, Semi Clean, etc.)	Location of Equipment (Lab Name)	Cleanliness of Lab
Number of Samp		k):			

Process Desertical etch)	cipe for litho and			

We agree to acknowledge the MTJ Sputter at IITBNF, Dept of Electrical Engineering, Central Facility of IIT Bombay in our Publications/Reports/Thesis in which the data is used.

<sup>\*</sup> Other details required would be communicated to the user depending on the submitted request.